



11-18-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Cheng Guo et al.

Serial No.: 09/361,682

Filed: July 27, 1999

Title: PROCESS GAS DISTRIBUTION  
FOR FORMING STABLE FLUORINE-  
DOPED SILICATE.

§ Group Art Unit: 1756

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§ Examiner: MARK HUFF

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§ Attorney Docket No.:AM5264

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\$  
12/16/02  
#4/RT (mw)  
Election  
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NOV 20 2002  
TC 1700

Date: November 14, 2002

**RESPONSE TO RESTRICTION REQUIREMENT UNDER 37 C.F.R. 1.143**

Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

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DEC 13 2002  
TC 1700

Sir:

The present communication is in response to the Office Action dated October 8, 2002, outlining the Examiner's restriction requirement between Method Claims 1-23 and Mask Assembly Claims 24-46.

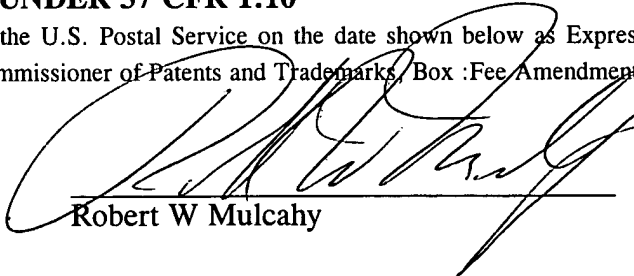
In response to the Examiner's requirement of election of claims, Applicant's undersigned Attorney hereby elects Method Claims 1-23 for prosecution, with traverse.

**EXPRESS MAIL UNDER 37 CFR 1.10**

I hereby declare that this paper is being deposited with the U.S. Postal Service on the date shown below as Express Mail, Mailer No. EL263802012US addressed to the: Commissioner of Patents and Trademarks, Box :Fee Amendment, Washington D.C. 20231.

Date

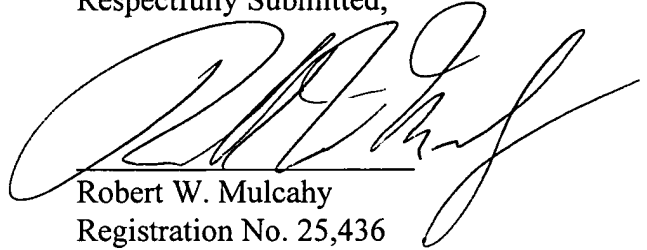
11/14/02

  
Robert W Mulcahy

EL263802012US

Applicant's undersigned attorney invites any direct telephone communication from the Examiner to expedite prosecution of the subject Application.

Respectfully Submitted,

A handwritten signature in black ink, appearing to read 'R. W. Mulcahy', written over a horizontal line.

Robert W. Mulcahy  
Registration No. 25,436  
Attorney for Applicant  
(408)-563-2726

Correspondence Address:  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. (AM5264/elith/RM)

November 14, 2002

Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Re: Inventor: Cheng Guo et al.  
Title: Methods for Fabricating Lithography Apparatus

Serial No: 09/698,706

Filing Date: October 27, 2000

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TC 1700

Transmitted herewith is a **Response to Restriction Requirement under 37 CFR § 1.143** in the above-identified patent application.

☐ No additional fee is required.

☒ The fees have been calculated or outlined below.

FEE CALCULATION					
Fee Items	Claims Remaining After Amendment	Highest Number of Claims Previously Paid For	Present Extra Claims	Fee Rate	Total
Total Claims	46	46	0	X\$18.00	\$00.00
Independent Claims	7	7	0	X\$84.00	\$00.00
TOTAL FEES					\$ 00.00

Applicant petitions for an extension of time, the fees for which are set out in 37 CFR 1.17(a)-(d), for the total number of months checked below:

Extension (months)	Fee for other than small entity
<input checked="" type="checkbox"/> One Month	<u>\$110.00</u>
<input type="checkbox"/> Two Months	\$400.00
<input type="checkbox"/> Three Months	\$950.00
<input type="checkbox"/> Four Months	\$1,510.00

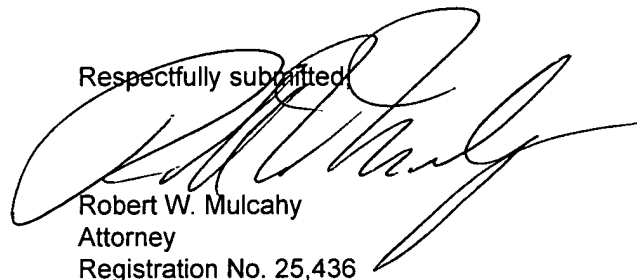
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TC 1700

If an additional extension of time is required please consider this a petition therefor.

XX The Commissioner is hereby authorized to charge the total amount of \$110.00 to Deposit Account No. 50-1074.

XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

Respectfully submitted,



Robert W. Mulcahy  
Attorney

Registration No. 25,436

Express Mailer Label No. EL263802012US addressed to: Box: Fee Amendment, Assistant Commissioner of Patents and Trademarks, Washington, D.C. 20231.